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Rickard K. DeMille, Reg. No. 58,471

Name of applicant, assignee or

Registered Representative

/Rickard K. DeMille, Reg. No. 58,471/

Signature

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. of: Ronald Kakoschke et al.

Appln. No.: 10/521,528

Filed: November 3, 2005

For: VERTICAL FIELD-EFFECT  
TRANSISTOR

Attorney Docket No: 10808/208

Examiner: Solerno, Sarah Kate

Art Unit: 2814

Confirmation No.: 8779

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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In accordance with the duty of disclosure under 37 CFR §1.56 and §§1.97-1.98, and more particularly in accordance with 37 CFR §1.97(d), Applicant hereby cites the following reference(s):

FOREIGN PATENT DOCUMENTS		
DOCUMENT NO.	DATE	COUNTRY
2000-049245	February 18, 2000	Japan
03-145761	June 20, 1991	Japan
10-107280	April 24, 1998	Japan
05-029560	February 5, 1993	Japan
04-226075	August 14, 1992	Japan
10-29007	January 31, 1989	Japan

FOREIGN PATENT DOCUMENTS		
DOCUMENT NO.	DATE	COUNTRY
2003-526948	August 9, 2003	Japan
EP 0459771 A3	December 4, 1991	EPO

Applicant is enclosing Form PTO-1449 (one sheet), along with a copy of each listed reference for which a copy is required under 37 CFR §1.98(a)(2). Pursuant to the undersigned attorney's obligation and duties under 37 C.F.R. §§ 1.56 and 1.98(a)(3) and (c), English language abstract of Japanese Laid-Open Publications Nos. 200-049245, 03-145761, 10-107280 and 05-029560 are included. Japanese Laid-Open Publication 10-29007 corresponds to previously-cited European Application No. 0872895, Japanese Laid-Open Publication No. 2003-526948 corresponds to previously-cited WO 01/69684 A2, and Japanese Laid-Open Publication 04-226075 corresponds to European Application No. 0459771. Applicant also includes herewith an English translation of a foreign office action issued in a related case. Applicant respectfully requests the Examiner's consideration of the above references and entry thereof into the record of this application.

By submitting this Statement, Applicant is attempting to fully comply with the duty of candor and good faith mandated by 37 CFR §1.56. As such, this Statement is not intended to constitute an admission that any of the enclosed references, or other information referred to therein, constitutes "prior art" or is otherwise "material to patentability," as that phrase is defined in 37 CFR §1.56(a).

The Applicant or Applicants certifies under 37 CFR §1.97(e)(1) that each item of information in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement (a copy of any foreign communication first citing a listed reference is attached for the Examiner's reference). Applicant has further calculated a processing fee in the amount of \$180.00 to be due under 37 CFR §1.17(p) in connection with the filing of this Information Disclosure Statement. Applicant has enclosed a check covering this fee, or authorized

charging the fee to a deposit account or credit card, as indicated in the Transmittal accompanying this Information Disclosure Statement.

Respectfully submitted,

March 27, 2009  
Date

/Rickard K. DeMille, Reg. No. 58,471/  
Rickard K. DeMille, (Reg. No. 58,471)